



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Kamal Kisho Goundar
Appl. No. : 10/616,163
Filed : July 9, 2003
For : METHOD OF FORMING
SILICON CARBIDE FILMS
Examiner : Monica D Harrison
Group Art Unit : ~~2829~~ 2813

CERTIFICATE OF MAILING

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

October 18, 2005

(Date)


Katsuhiro Arai, Reg. No. 43,315

RESPONSE TO FINAL OFFICE ACTION

Mail Stop AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

This is in response to the Office Action mailed July 27, 2005. Please reconsider the present application in light of the following comments.

Remarks/Arguments begin on page 2 of this paper.